505016293 07/23/2018

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
JIAN GANG LU	05/03/2018
FU CHENG CHEN	05/03/2018

RECEIVING PARTY DATA

Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION	
Street Address:	18 ZHANGJIANG ROAD, PUDONG NEW AREA	
City:	SHANGHAI	
State/Country:	CHINA	
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (BEIJING) CORPORATION	
Street Address:	NO. 18 WEN CHANG RD., ECONOMIC-TECHNOLOGICAL DEVELOPMENT AREA, DAXING DISTRICT	
City:	BEIJING	
State/Country:	CHINA	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	16042846

CORRESPONDENCE DATA

Fax Number:

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NAME OF SUBMITTER: WENDY LIN

SIGNATURE: /Wendy Lin/

PATENT 505016293 REEL: 046432 FRAME: 0566

DATE SIGNED: 07/23/2018

Total Attachments: 2
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PATENT REEL: 046432 FRAME: 0567 SMIC 2016-02062-SH-US Anova Law Group, PLLC 00158.0533.00US

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ASSIGNMENT AND DECLARATION

WHEREAS I/We, the below named inventor(s) (hereinafter referred to as Assignor(s)) have mad an invention entitled:
PACKAGING STRUCTURE AND FABRICATION METHOD THEREOF
for which I/We executed an application for United States Letters Patent concurrently herewith or filed an application for United States Letters Patent on(Application No); and
WHEREAS, Semiconductor Manufacturing International (Shanghai) Corporation, a corporation of P. R. China whose post office address is 18 Zhanghais Road, Pudong New Area, Shanghai, China 201203, and Semiconductor Manufacturing International (Beijing) Corporation, a corporation of P. R. China whose post office address is No. 18. Wen Chang Rd., Economic-Technological Development Area Daxing District, Beijing, China 100716 (hereinafter referred to as Assignee), is desirous of securing the entire right, title, and interest in and to this invention in all countries throughout the world, and in and to the application for United States Letters Patent on this invention and the Letters Patent to be issued upor this application;
NOW THEREFORE, be it known that, for good and valuable consideration the receipt of which from Assignee is hereby acknowledged, I/We, as Assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the Assignee, its lawful successors and assigns, my/our entire right, title, and interest in and to this invention, provisional Application No
AND, I/WE HEREBY covenant that I/We have the full right to convey the interest assigned by this Assignment, and I/We have not executed and will not execute any agreement in conflict with this Assignment;
AND, I/WE HEREBY further covenant and agree that I/We will, without further consideration, communicate with Assignee, its successors and assigns, any facts known to me/us respecting this invention, and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver any and all papers that may be necessary or desirable to perfect the title to this invention in said Assignee, its successors or assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid Assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States and any foreign country, it being understood that any expense incident to the execution of such papers shall be borne by the Assignee, its successors and assigns.
AND, I/WE HEREBY authorize and request the attorneys I/we have empowered in the Declaration and Power of Attorney in this application, to insert here in parentheses (Application No

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Further, as a belov	v named inventor, I hereb	y declare that:	
This declaration is	directed to the application	n attached hen	eto or United States application or PCT
If the application is not atta number as set forth above		ion is as identif	d on ied above or by the attorney docket
The above-identific	ed application was made	or authorized t	o be made by me.
I believe that I am application.	the original inventor or an	n original joint li	nventor of a claimed invention in the
I have reviewed an claims.	nd understand the content	ts of the above	-identified application, including the
37, Code of Federal Regula	ations § 1.56, including for available between the fili	r continuation-i ng data of the	aterial to patentability as defined in Title n-part applications, material prior application and the national or
I hereby acknowie 18 U.S.C. §1001 by fine or	dge that any willful felse s imprisonment of not mor	statement mad e than five (5)	e in this declaration is punishable under years, or both.
IN TESTIMONY V	/HEREOF, I/We have her	reunto set our l	nands.
Inventor 1 Legal Name:	Jian Gang LU		
Signature:	HRAN	Date:	<u> </u>
Inventor 2 Legal Name:	Fu Cheng CHEN		
Signature:	P.F. 160 0%	Date:	20(8: 3: 3
Note: An application data she accompany this form or must list additional inventors.	eet (PTO/SB/14 or equivalen have been previously filed.	nt), including nan Check the box	ning the entire inventive entity, must below and complete the attached page(s) to
Additional inventors are	being named on the supp	olemental sheet(s) attached hereto.

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